



DO NOT ENTER: /J.L./

11/06/2008

JL AF

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

ITOH ET AL.

Atty. Ref.: 1035-646; Confirmation No. 4549

Appl. No. 10/589,003

TC/A.U. 2812

Filed: August 10, 2006

Examiner: Jae LEE

For: GROUP I-VII SEMICONDUCTOR SINGLE CRYSTAL THIN FILM AND PROCESS  
FOR PRODUCING SAME

\* \* \* \* \*

October 30, 2008

Mailbox AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL REJECTION  
AND REQUEST FOR RECONSIDERATION**

In response to the Final Office Action, dated August 20, 2008, Applicants amend the  
above-identified application in the following manner: